

APPLICATION DATA SHEET

Application Information

Application Type::	Regular
Subject Matter::	Utility
Title::	PROCESS FOR PREPARING A STABILIZED IDEAL OXYGEN PRECIPITATING SILICON WAFER
Attorney Docket Number::	MEMC TP-01-2450 (3009)
Total Drawing Sheets::	4
Small Entity?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	US
Status::	Full Capacity
Given Name::	Robert
Family Name::	Falster
City of Residence::	London
State or Province of Residence::	England
Country of Residence::	United Kingdom
Street of Mailing Address::	22 Compton Terrace
City of Mailing Address::	London
State or Province of Mailing Address::	England
Postal Code of Mailing Address::	N1 2UN

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Russia
Status::	Full Capacity
Given Name::	Vladimir
Family Name::	Voronkov
City of Residence::	Merano
State or Province of Residence::	Bolzano
Country of Residence::	Italy

Street of Mailing Address:: Via Nazionale, 59
City of Mailing Address:: Merano
State or Province of Mailing
Address:: Bolzano
Postal Code of Mailing Address:: 39012

Correspondence Information

Correspondence Customer Number:: 000321

Representative Information

Representative Customer Number:: 000321

Assignee Information

Assignee Name:: MEMC Electronic Materials, Inc.